

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	TOMINAGA KOJI ET AL.	)
		) Group Art Unit: 2813
Serial No.:	10/550,805	)
		) Examiner: Luke, Daniel M.
Filed:	July 12, 2006	)
		) Confirmation No. 3990
For:	METHOD FOR FORMING AN	)
	INSULATING FILM IN A	)
	SEMICONDUCTOR DEVICE	)

**VIA EFS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

This amendment is respectfully submitted in response to the Office Action dated September 14, 2007. Applicants hereby respectfully petition for a one-month extension of time. If there are any charges with respect to this Amendment or otherwise, please charge them to Deposit Account No. 06-1130 maintained by Applicants' attorneys.

Please amend the Application as follows: